

Patent Application Transmittal

(only for new nonprovisional applications under 37 C.F.R. 1.53(b))

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Date: <u>June 25, 2003</u>
Attorney Docket No.: <u>450100-04610</u>

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

With reference to the filing in the United States Patent and Trademark Office of an application for patent in the name(s) of:

Tetsujiro KONDO, Hideo NAKAYA, Tsutomu ICHIKAWA, Takao INOUE

entitled:

ACTIVE MATRIX DISPLAY DEVICE, VIDEO SIGNAL PROCESSING DEVICE, METHOD OF DRIVING THE ACTIVE MATRIX DISPLAY DEVICE, METHOD OF PROCESSING SIGNAL, COMPUTER PROGRAM EXECUTED FOR DRIVING THE ACTIVE MATRIX DISPLAY DEVICE, AND STORAGE MEDIUM STORING THE COMPUTER PROGRAM

<u>X</u> X	following are enclosed: _ Specification (27 pages) _ <u>9</u> Sheet(s) of Drawings _ <u>22</u> Claim(s) (including <u>12</u> independent claim(s)) _ This application contains a multiple dependent claim
<u> x</u>	Our check for <u>\$ 1542.00</u> , calculated on the basis of the claims as amended by any enclosed preliminary amendment as follows:
	Basic Fee, \$750.00 (\$375.00)
<u>X</u>	_ Oath or Declaration and Power of Attorney New signed _X_ unsigned Copy from a prior application (37 C.F.R. 1.63(d))
<u> x</u>	_ Certified copy of each of the following application(s) to substantiate the claim(s) for priority made in the Declaration:

Application No.

<u>Filed</u>

<u>In</u>

2002-187998

27 June 2002

Japan

Please charge any additional fees required for the filing of this application or credit any overpayment to Deposit Account No. 50-0320.

2000

PATENT TRADEMARK OFFICE

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP Attorneys for Applicants

William S. Frommer Reg. No. 25,506

"Express Mail" mailing label number EV345018322US
Date of Deposit June 25, 2003
I hereby certify that this paper or fee, and a patent
application and accompanying papers, are being deposited with th
United States Postal Service "Express Mail Post Office to
Addressee" service under 37 CFR 1.10 on the date indicated above
and are addressed to the Mail Stop Patent Application,
Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-
1450.

(Typed or printed name of person mailing paper or fee)

(Signature of person mailing paper or fee)

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Mail Stop Patent Application

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Re:

U.S. Patent Application

Applicants: Tetsujiro KONDO, Hideo NAKAYA, Tsutomu ICHIKAWA,

Takao INOUE

Our Ref.: 450100-04610

Dear Sir:

Enclosed are papers constituting the above patent application which is being filed under 37 C.F.R. 1.53 without a signed Declaration. Please accord a filing date and a serial number to such application and inform the undersigned thereof so that a signed Declaration and the surcharge required by 37 C.F.R. 1.16(e) may be duly filed.

Please address all correspondence to:

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Respectfully,

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Enclosures